

# Status of X-ray Pinhole Cameras for 3GSLS

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## ≈ 400 – 300 BC : Earliest written observations

Chinese philosopher Mozi [1].

*“Why does the sun penetrating through quadrilaterals form not rectilinear shapes but circles, as for instance when it passes through wicker-work?”*

Greek philosopher Aristotle (384-322 BC) [2].

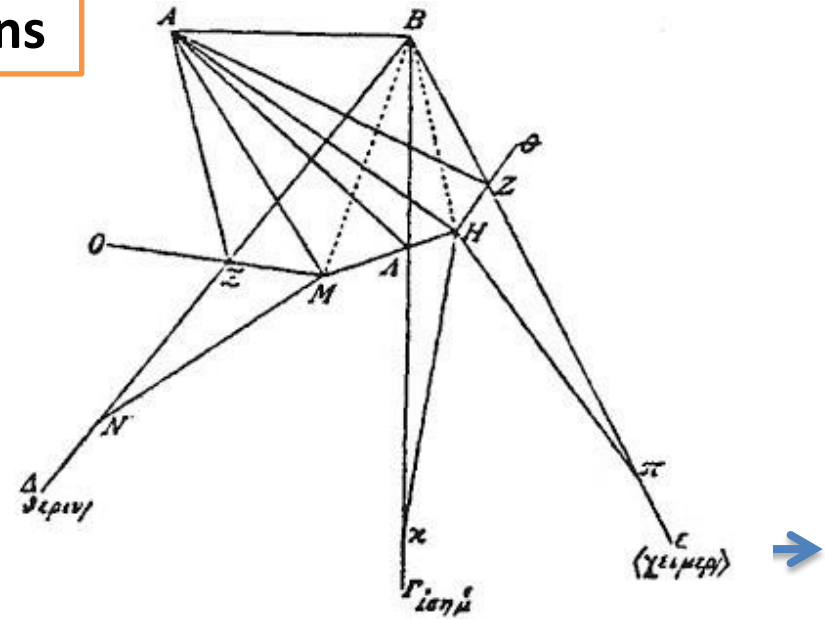


Time

Observation of a partial solar eclipse through overlapping fingers that Aristotle could not explain [3].

≈ 400 – 300 BC : Earliest written observations

Light ray diagram by Anthemius of Tralles [3].



## 500 – 1100 AD : First experimental studies

555 AD: Ray-tracing diagram by Anthemius of Tralles (mathematician and co-architect of the Hagia Sophia) [3].

965 – 1039 AD: Optical scientist Ibn al-Haitham (Alhazen) describes imaging candles in a darkened room using a pinhole and states:

*“The image of the Sun at the time of the eclipse, unless it is total, demonstrates that when light passes through a narrow, round hole and is cast on a plane opposite to the hole, it takes on the form of a moonsickle.”*



≈ 400 – 300 BC : Earliest written observations

## 1100 – 1400 AD : Finding applications

Theodoric of Freiberg and Kamal al-Din al Farisi simultaneously and independently study the colour theory of sunlight using a pinhole.

≈1300 AD: Roger Bacon uses science to reaffirm religious belief [3].

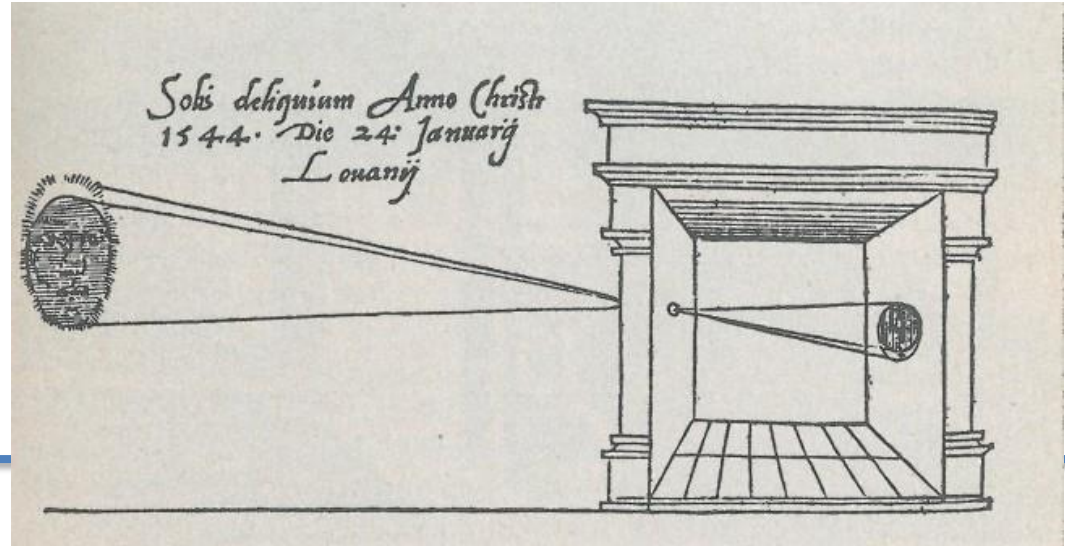
Drawing of a 3-tiered camera  
by Roger Bacon.



500 – 1100 AD : First experimental studies

≈ 400 – 300 BC : Earliest written observations

1100 – 1400 AD :  
Finding applications



Schematic of a pinhole camera in 1545 [3].

**1400 – 1600 AD : Renaissance of human understanding**

Optical and astronomical experiments by Antonio de Dominus, René Descartes, Tycho Brahe, Johannes Kepler and Leonardo da Vinci.

1545 AD: First published picture of a pinhole camera obscura in the book, *De Radio Astronomica et Geometrica*, by Gemma Frisius [3].

**500 – 1100 AD : First experimental studies**

**≈ 400 – 300 BC : Earliest written observations**

**1100 – 1400 AD :  
Finding applications**

**1600 – 1900 AD : Replaced by lenses**

Pinhole aperture replaced by a lens in the majority of camera obscuras.

David Brewster describes pinhole camera photography in his book, *The Stereoscope*, in 1856 [3].

**1400 – 1600 AD : Renaissance of human understanding**

**500 – 1100 AD : First experimental studies**

Time



≈ 400 – 300 BC : Earliest written observations

1100 – 1400 AD :  
Finding applications

1600 – 1900 AD : Replaced by lenses

**1900 – Now : Rise of scientific pinhole cameras**  
Pinhole cameras coupled with films, scintillators, lenses and modern camera sensors are used in high energy physics.

→ **Transverse profiling of particle beams in light sources.**

1400 – 1600 AD : Renaissance of human understanding

500 – 1100 AD : First experimental studies

Time

# Principle of Operation

- Synchrotron radiation is emitted from the source point.
- Intermediate image is formed at the scintillator screen via a pinhole.
- Image is relayed to the camera by a lens.

----- X-rays

----- Visible  
light

Source-to-scintillator magnification  $|M_1| = \left| -\frac{d_i}{d_o} \right|$

Scintillator-to-camera magnification  $|M_2| \sim 1$

Source

Pinhole

Lens

Camera

Mirror

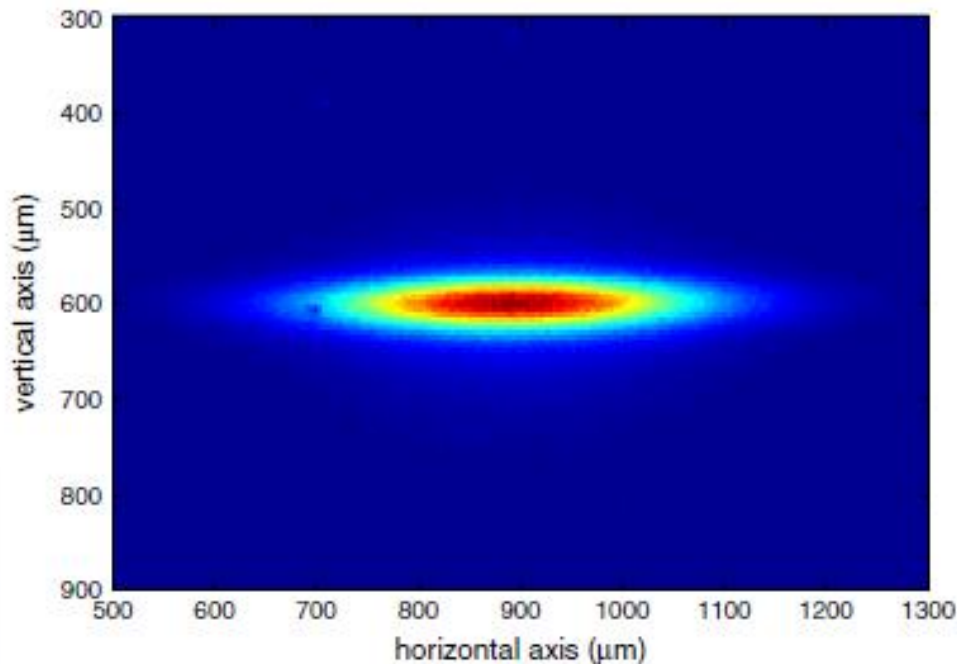
Scintillator

$d_o$

$d_i$



X-ray pinhole cameras **measure the transverse profile** of the beam, **from which the emittance may be calculated.**



Example image from Diamond Light Source in 2010, from which the emittance can be calculated [4, 5].

At Diamond using two pinhole cameras at different locations:

1. **Fit a 2D Gaussian** to obtain horizontal and vertical imaged sizes  $\sigma_{x_{1,2}}^{image}$  and  $\sigma_{y_{1,2}}^{image}$  respectively.
2. **Deconvolve and scale** using magnification to obtain the electron beam sizes e.g. Gaussian subtraction in quadrature:

$$\sigma_{y_1} = \frac{\sqrt{(\sigma_{y_1}^{image})^2 - \sigma_{PSF}^2}}{M_1}$$

3. Given the lattice parameters, **solve** the following matrix equation to obtain the horizontal and vertical emittances  $\varepsilon_{x,y}$ , and energy spread  $\sigma_e$ :

$$\begin{bmatrix} \sigma_{x_1}^2 \\ \sigma_{x_2}^2 \\ \sigma_{y_1}^2 \\ \sigma_{y_2}^2 \end{bmatrix} = \begin{bmatrix} \beta_{x_1} & 0 & \eta_{x_1}^2 \\ \beta_{x_2} & 0 & \eta_{x_2}^2 \\ 0 & \beta_{y_1} & \eta_{y_1}^2 \\ 0 & \beta_{y_2} & \eta_{y_2}^2 \end{bmatrix} \begin{bmatrix} \varepsilon_x \\ \varepsilon_y \\ \sigma_e^2 \end{bmatrix}$$

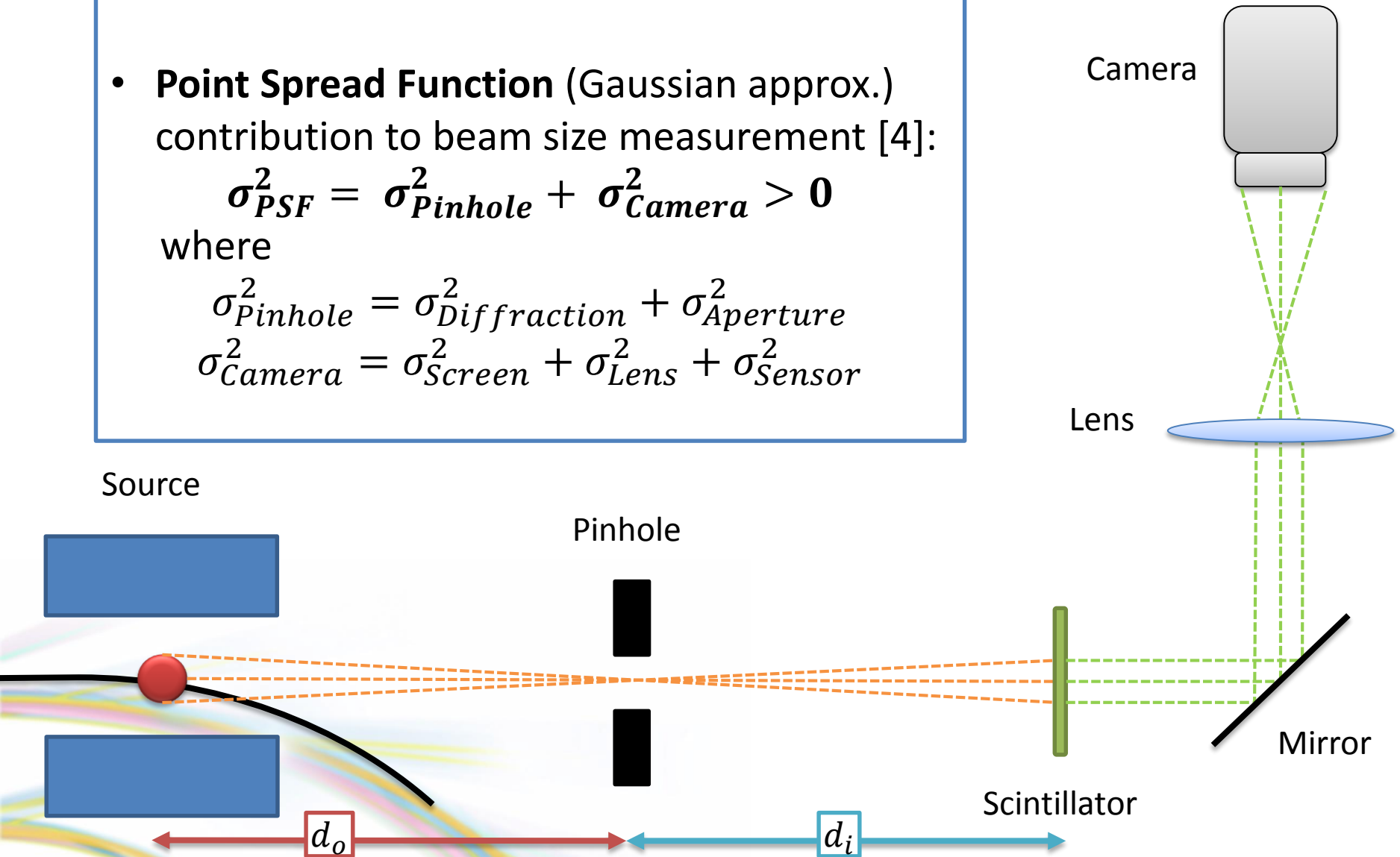
- Indirect emittance measurement
- **Point Spread Function** (Gaussian approx.)  
contribution to beam size measurement [4]:

$$\sigma_{PSF}^2 = \sigma_{Pinhole}^2 + \sigma_{Camera}^2 > 0$$

where

$$\sigma_{Pinhole}^2 = \sigma_{Diffraction}^2 + \sigma_{Aperture}^2$$

$$\sigma_{Camera}^2 = \sigma_{Screen}^2 + \sigma_{Lens}^2 + \sigma_{Sensor}^2$$



$$\sigma_{PSF}^2 = \sigma_{Pinhole}^2 + \sigma_{Camera}^2 > 0$$

Source resolution for optimised pinhole camera, given current spatial constraints at Diamond:

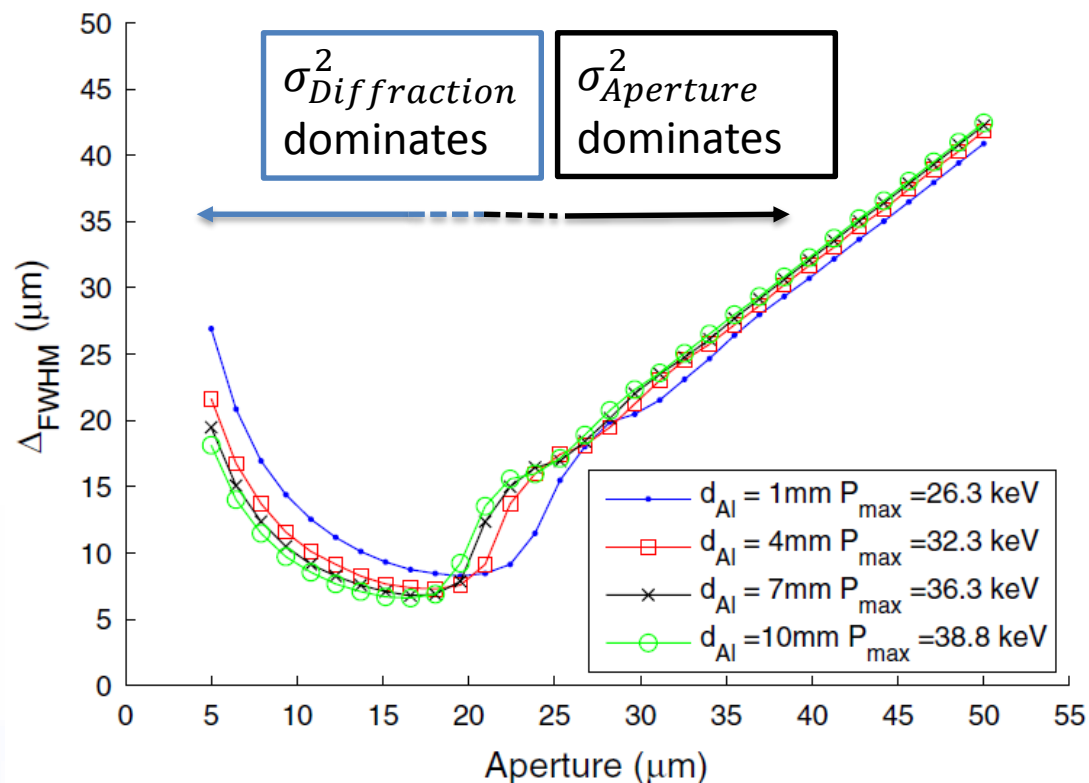
$$\frac{\left(\frac{\Delta_{FWHM}}{2.35}\right)}{|M_1|} \sim \frac{\left(\frac{6 \mu\text{m}}{2.35}\right)}{2.65} \sim 1 \mu\text{m}$$

with  $\sigma_{Camera}^2 = 0$ .

Source resolution incl. contribution from camera using a 5 $\mu\text{m}$  P43 screen [4]:

$\sim 3 \mu\text{m}$

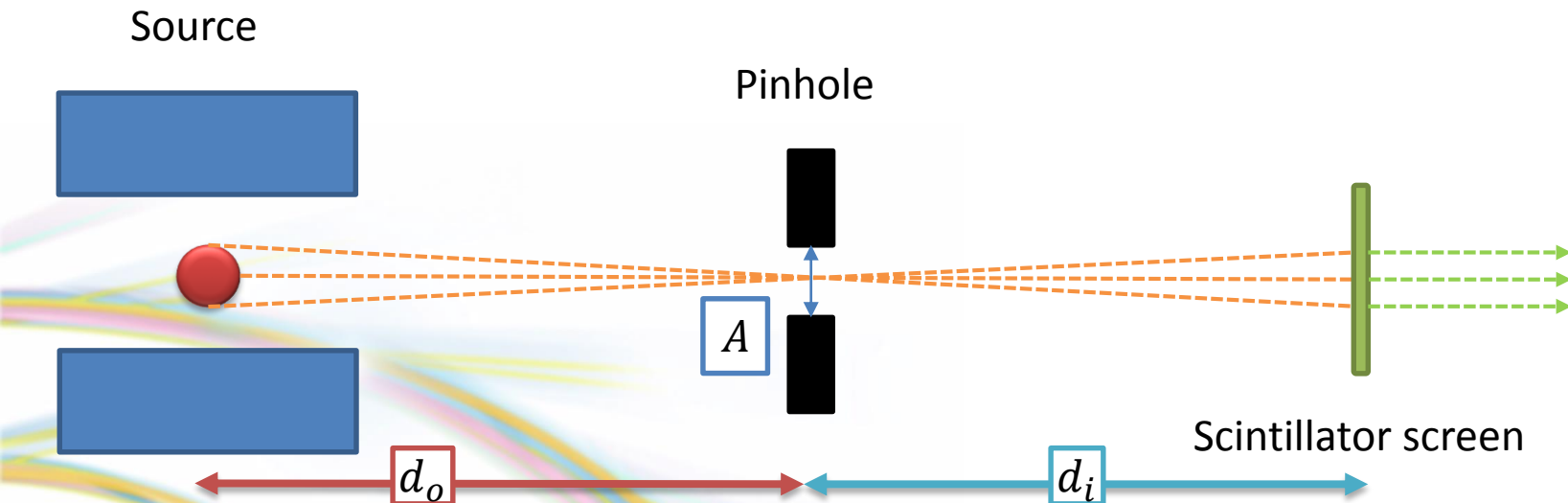
Phys. Rev. ST Accel. Beams **13**, 022805 (2010)



- Spatial constraints

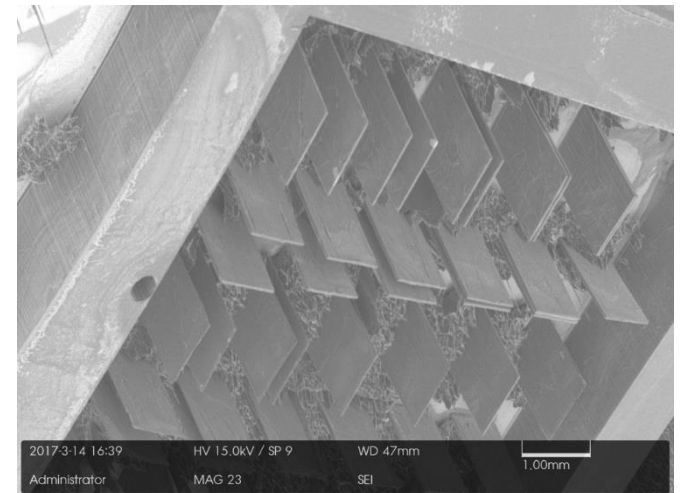
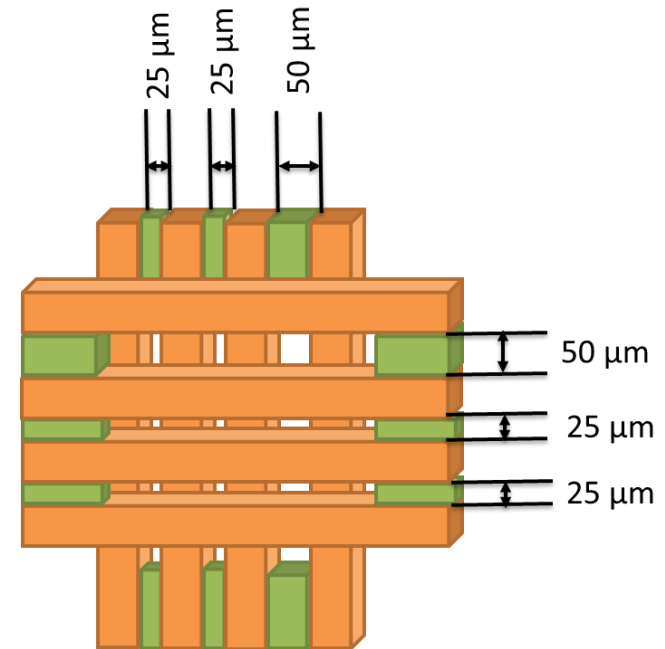
- For sufficient source-to-screen magnification ( $|M_1| = \left| -\frac{d_i}{d_o} \right| \geq 2$ ):  
 $\rightarrow$  X-ray path length ( $d_o + d_i$ )  $\geq 10\text{m}$
- Diffraction contribution to PSF from pinhole worsens with distance given a fixed aperture size  $A$ :

$$\sigma_{\text{Diffraction}} = \frac{\sqrt{12}}{4\pi} \frac{\lambda d_i}{A} \quad \text{for wavelength } \lambda \text{ [5].}$$



- Pinhole fabrication

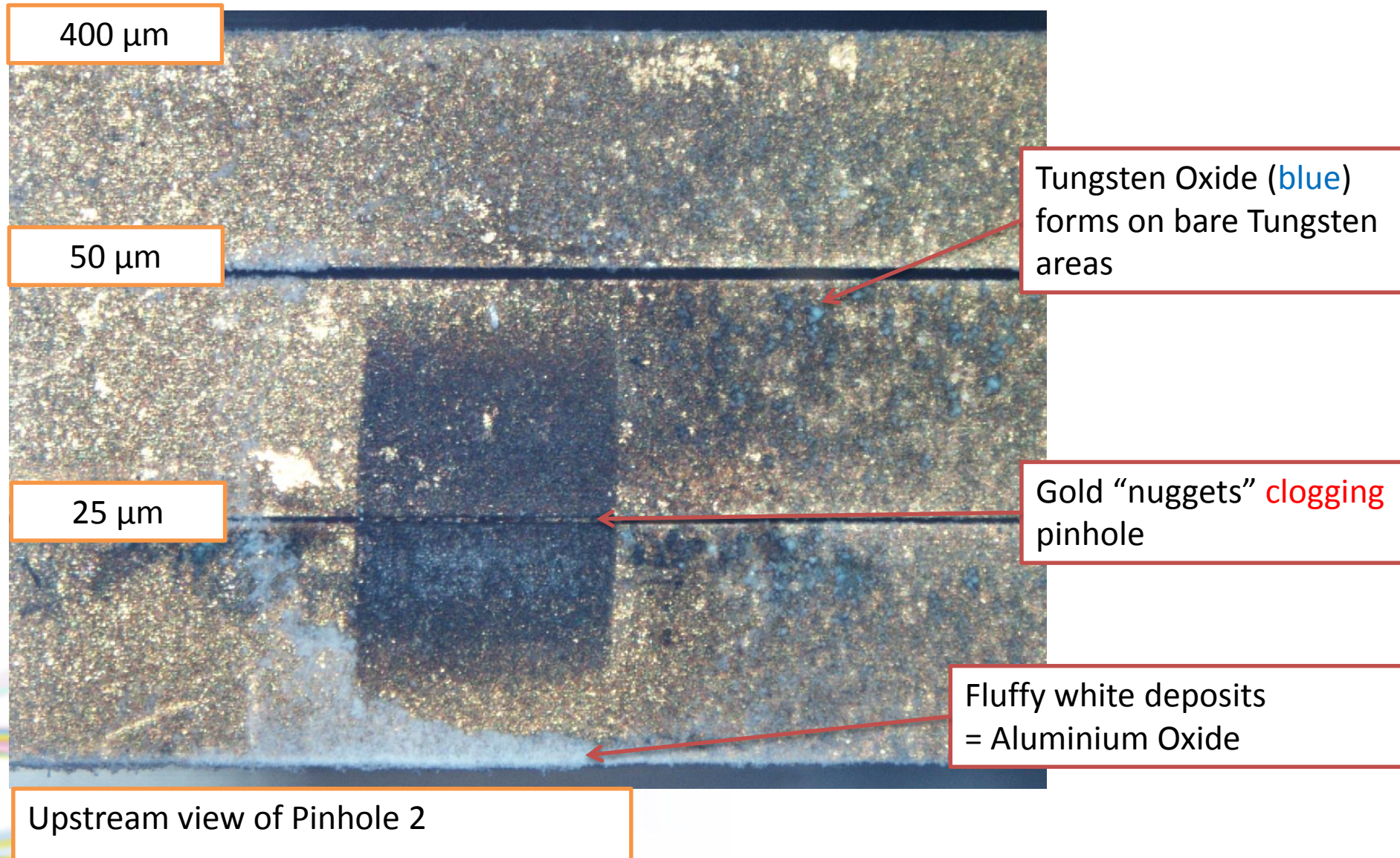
- For the pinhole to be opaque to keV X-rays a **high Z material** is required e.g. 1mm thick Tungsten.
- Often these materials are **difficult to machine**.
- Especially given the **high aspect ratio**  
10  $\mu\text{m}$  (aperture): 1mm (thickness)  
→ **1:100**



- Environment and oxidation

- Air, nitrogen or vacuum?
- Lifetime and **maintenance considerations**





- Low photon flux through pinhole
  - Monochromatic vs white beam? Attenuation?
  - Generally a **multi-turn diagnostic** given tens of ms exposure time
- Knowledge of the lattice parameters
  - **Errors on the lattice parameters from LOCO** will propagate to the error on the obtained emittance
- PSF contribution
  - $\sigma_{PSF} > 0$
  - Thus some post-processing **deconvolution** is needed
  - Simulation of the PSF is not trivial
- Cost



- Simple design. Simple alignment. Simple maintenance. Simple analysis. Simple...
  - Quick to commission e.g. < 1 week at Diamond (2006)
  - So simple, a human can learn a lot just by looking...!
- Provides 2D transverse profile.
- Non-invasive.
- Cheap options are available.
- Possible to custom build the imager to optimise for spatial resolution, turn-by-turn acquisition, dynamic range etc.
- Fast image processing, thus suitable for feedback systems.

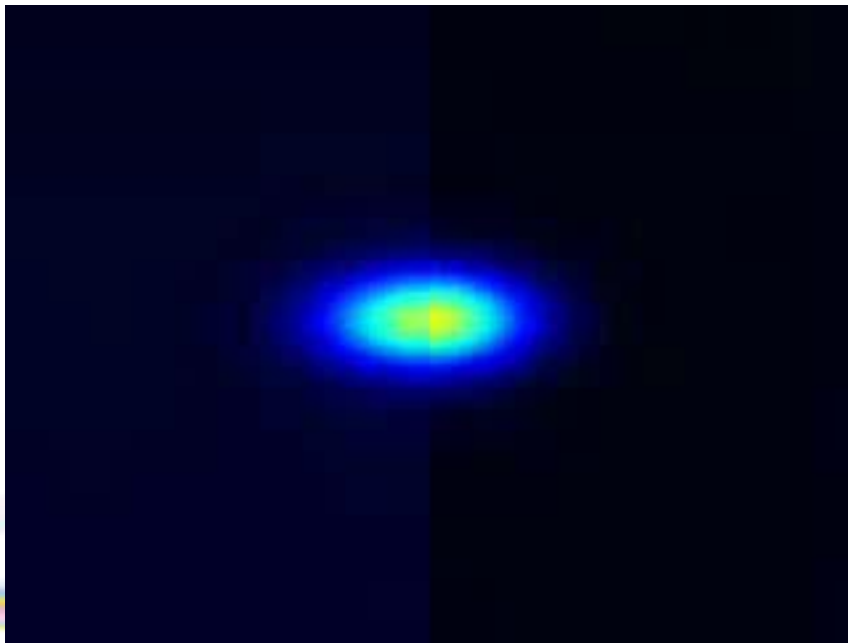
Emittance Monitoring

+

CCTV



*While we have human operators, the importance of easy human interpretation shouldn't be overlooked.*



Injection at Diamond 2015

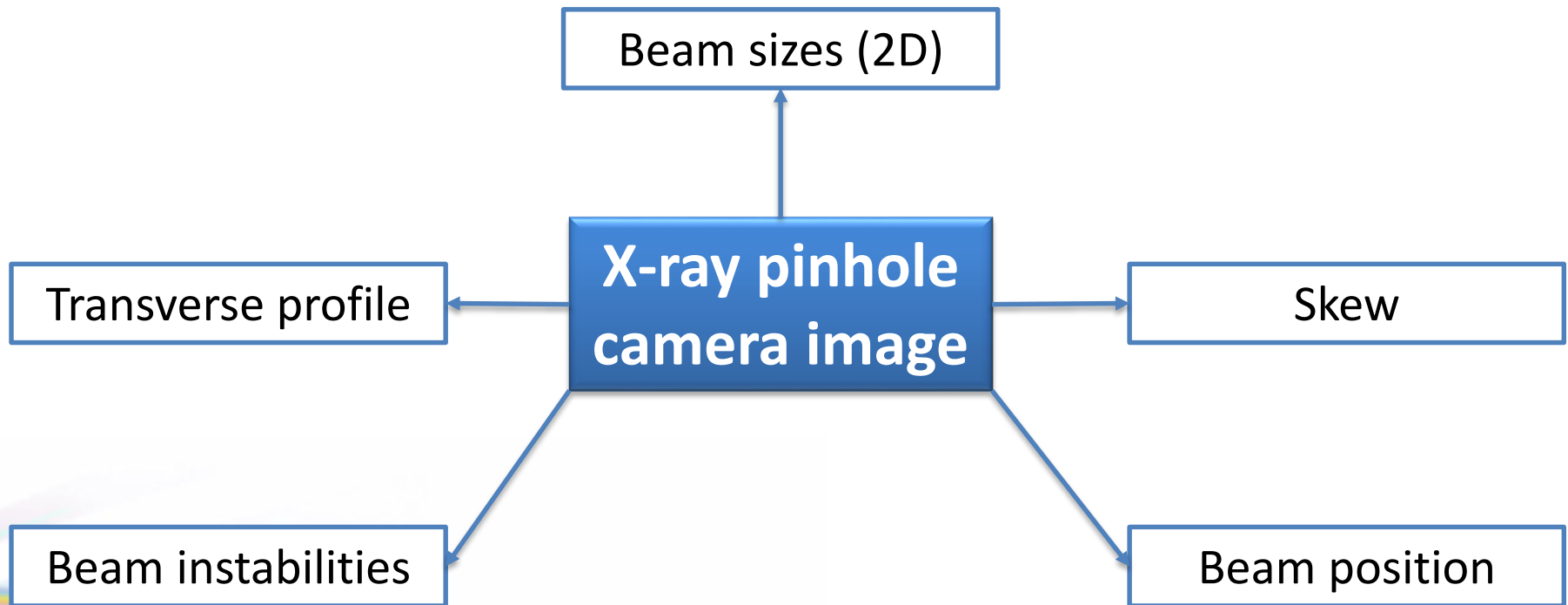


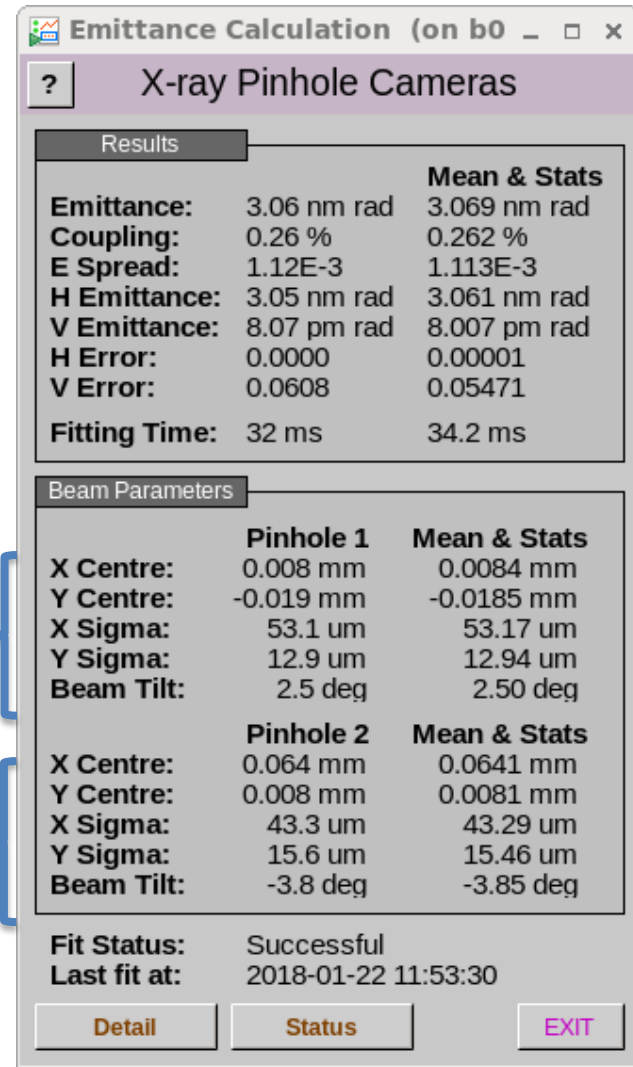
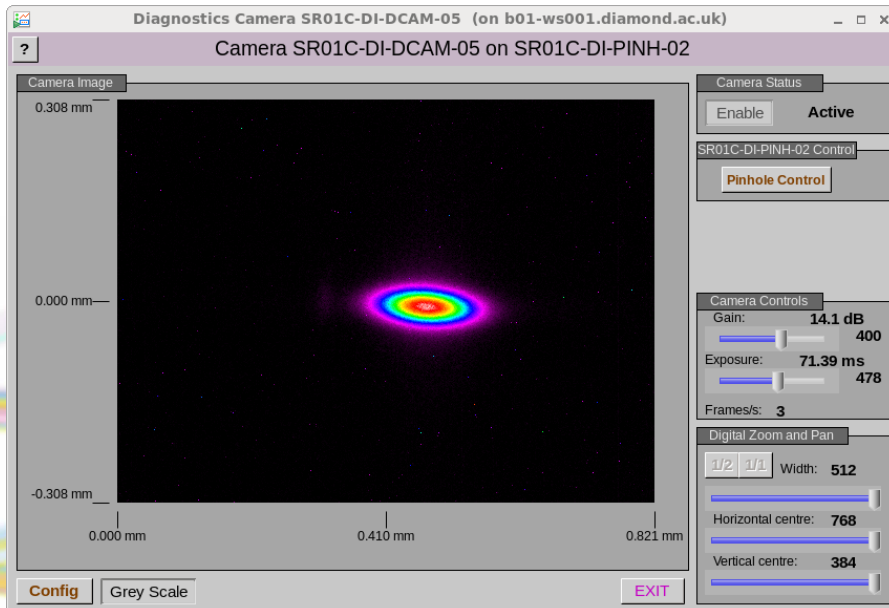
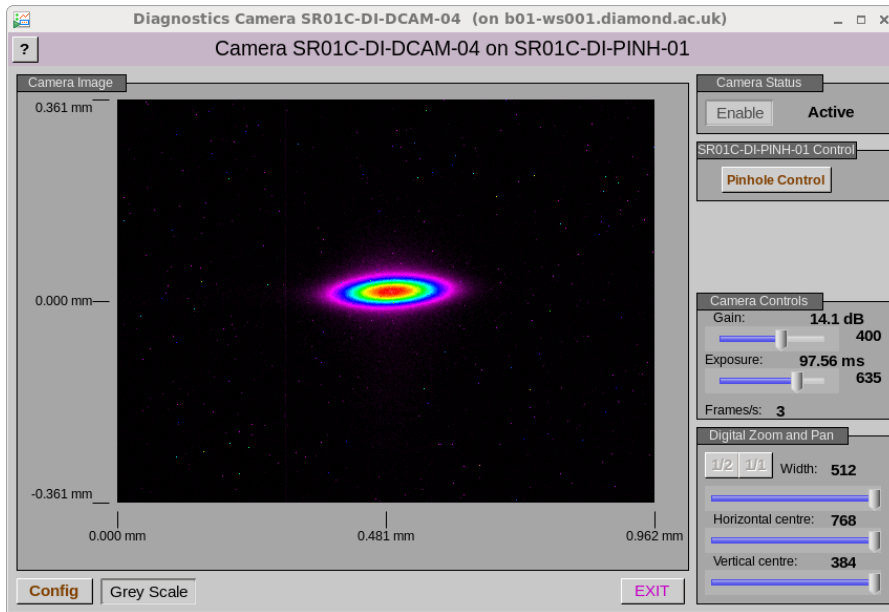
TMBF at Diamond 2015

**Emittance Monitoring**

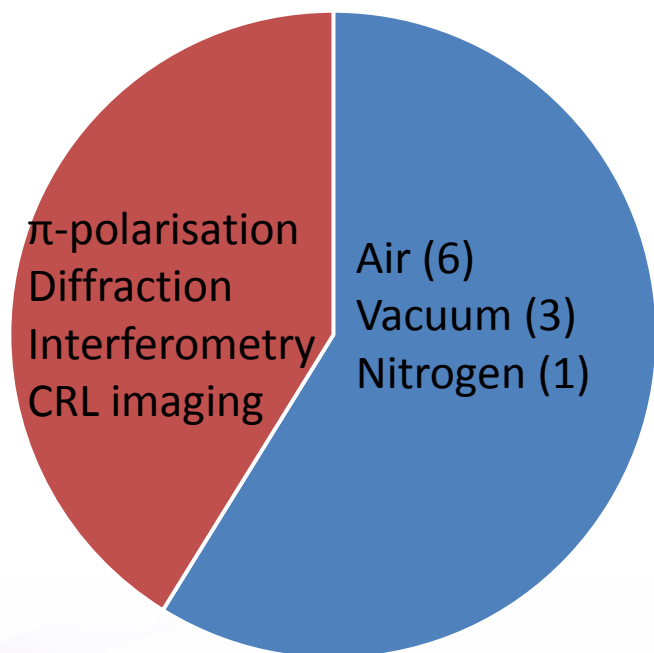
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**CCTV**



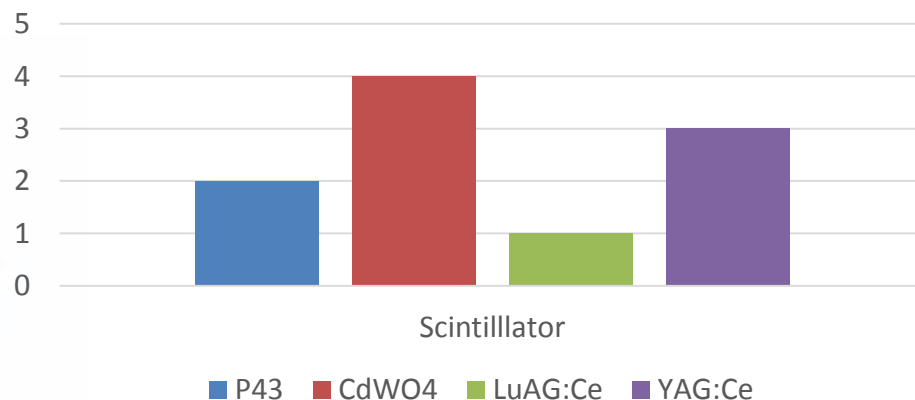


Do you use X-ray pinhole cameras for emittance measurement?



■ Yes (10) ■ No (7)

Parameter	Average
Aperture	23 μm
X-ray energy	29 keV
$\left(\frac{\sigma_{PSF}}{\sigma_y}\right) \times 100$	32 %
Source-to-screen magnification	1.6
Screen-to-camera magnification	1.8



■ P43 ■ CdWO4 ■ LuAG:Ce ■ YAG:Ce

- Simple! → Easy to commission → Easy maintenance
- Survey shows primary instrument for emittance monitoring
- Fundamental limitations, given space and 30 KeV X-rays etc., mean sub-micron beam size measurements are not possible.
- Many practical challenges are being improved with technological advances.
- Complementary general diagnostic → CCTV
- Suitable for emittance feedback
- Easy human interpretation

- [1] V. Popovic *et al.*, Design and Implementation of Real-Time Multi-Sensor Vision Systems, Springer, 2017.
- [2] E. S. Forster, Problemata by Aristotle, translated to English, Vol VII, 912b, 1927.
- [3] E. Renner, Pinhole Photography from Historic Technique to Digital Application, Fourth Ed., Focal Press, 2009.
- [4] C. Thomas *et al.*, *X-ray pinhole camera resolution and emittance measurement*, Phys. Rev. ST Accel. Beams **13**, 022805 (2010).
- [5] P. Elleaume *et al.*, J. Synchrotron Radiat. 2, 209 (1995).
- [6] M. Madou, ``Chapter 10: Micromolding Techniques - LIGA'', Fundamentals of Microfabrication and Nanotechnology, Vol. 2, Third Ed., CRC Press, 2012, p.591-642.
- [7] L.M. Bobb *et al.*, ``Performance Evaluation of Molybdenum Blades in an X-ray Pinhole Camera'', Proc. IBIC2016, p. 796-799.

**Thank you for your attention.**

Thanks to the Diamond Diagnostics group and to all those who participated in the survey!

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END



Challenge	Potential Solutions
Spatial constraints	Dedicated diagnostic beamlines?
Pinhole fabrication	Investigate alternative techniques e.g. LIGA [6], 3D printing and materials that can be machined [7].
Environment	Solutions are already available depending on desired accessibility and cost.
Low intensity	Increase numerical aperture to intensified camera? Use a new scintillator material with greater photon yield (see talk by G. Kube).
Error on lattice parameters	Improve LOCO?
PSF	Reduce PSF through upgrading components. Lucy-Richardson deconvolution algorithm given accurate simulation on PSF?